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IN AN APPLICATION

APPLICANT: Yuen et al.

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUB-CLASS	FILING DATE IF APPROPRIATE
(initialed)	5	3	4	6	5	8	6	09/13/1994	Keller			
	5	7	0	0	7	3	9	12/23/1997	Chiang et al.			
	5	7	7	6	8	3	2	07/07/1998	Hsieh et al.			
(initialed)	6	0	3	7	2	6	6	03/14/2000	Tao et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
												YES	NO

OTHER DOCUMENTS (*Including Author, Title, Date, Pertinent Pages, etc.*)

PCT Search Report for International Application No. PCT/US01/43478, dated 2/19/2003

EXAMINER George Goudreau	DATE CONSIDERED 7-03/

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.